ABSTRACT

Provided are a contact probe that can realize low adhesion property to an adherend (particularly, Sn contained in the adherend) and secure stable contact resistance over a long period of time, and a connection device including the same. The present invention relates to a contact probe which repeatedly contacts with an electrode, wherein a carbon film including a metal element is formed on a surface of the contact probe which contacts with the electrode, and a concentration of the metal element in the carbon film surface is lower than an average concentration thereof in a whole of the carbon film.